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**FACSIMILE COVER SHEET**

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**TO:** Examiner Ron E. Pompey      **FAX:** (703) 746-3919

**FROM:** May Lin DeHaan      **DATE:** March 5, 2003

**RE:** U.S. Patent Application Serial No. 09/826,472  
Entitled: "Method of Fabricating a Semiconductor Device Having a Nitride/High-K/Nitride Gate Dielectric Stack by Atomic Layer Deposition (ALD) (as amended)

**CONFIDENTIAL**

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Dear Examiner Pompey:

Please see the attached Informal Response to the outstanding Office Action for your consideration as per our Telephonic Interview of this morning.

As always, if you have any questions or concerns regarding this or any other matter, please do not hesitate to contact us.

Very truly yours,

LARIVIERE, GRUBMAN & PAYNE, LLP

*May Lin DeHaan*  
May Lin DeHaan

MLD/pa

THIS TRANSMISSION TOTALS 10 PAGE(S) INCLUDING COVER SHEET